



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

NELSON *et al.*

Appl. No. 09/841,187

Filed: April 25, 2001

For: Method and System for Improving  
Focus Accuracy in a Lithography  
System

Confirmation No.: 3650

Art Unit: 2851

Examiner: Esplin, D.

Atty. Docket: 1857.0350000

**Amendment And Reply Under 37 C.F.R. § 1.111**

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated June 19, 2003, Applicants submit the following  
Amendment and Remarks. This Amendment is provided in the following format:

- (A) Each section begins on a separate sheet;
- (B) Starting on a separate sheet, amendments to the specification by  
presenting replacement paragraphs marked up to show changes made;
- (C) Starting on a separate sheet, a complete listing of all of the claims:
  - in ascending order;
  - with status identifiers; and
  - with markings in the currently amended claims;
- (D) Starting on a separate sheet, the Remarks.

TECHNOLOGY CENTER 2800  
NOV 26 2003

RECEIVED

A petition for a one-month extension of time is filed herewith, along with the  
appropriate fee. It is not believed that any further extensions of time, or fees for net addition  
of claims, are required. If additional extensions of time are necessary to prevent

abandonment of this application, then such extensions of time are hereby petitioned under 37 C.F.R. § 1.136(a), and any fees required therefor (including fees for net addition of claims) are hereby authorized to be charged to our Deposit Account No. 19-0036.